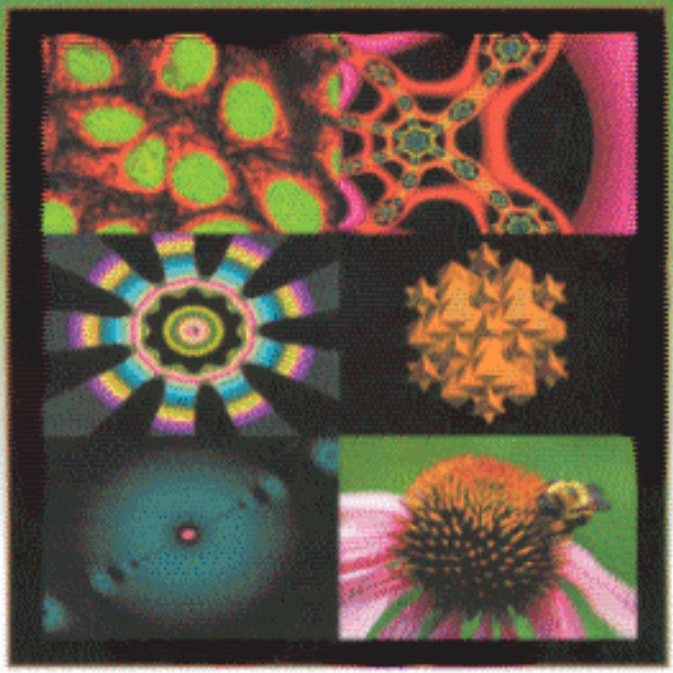
SECOND EDITION

Nano- and Micro-Electromechanical Systems

Fundamentals of Nano- and Microengineering



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